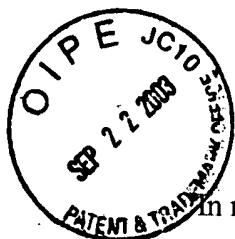


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2823
PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

TAKAHIRO YAJIMA ET AL.

Application No.: 09/900,043

Filed: July 9, 2001

For: THIN FILM FORMATION
METHOD

)
: Examiner: Trung Q. Dang
)
: Group Art Unit: 2823
)
:
)
:
)
: September 17, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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AMENDMENT

Sir:

a) Introductory Comments

In response to the Office Action dated June 17, 2003, kindly amend the
subject application as follows:

I hereby certify that this correspondence is being deposited with the
United States Postal Service as first-class mail in an envelope addressed
to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-
1450 on

September 17, 2003
(Date of Deposit)

PETER SAXON (24947)

(Name of Attorney for Applicant)

Peter Saxon

Signature

September 17, 2003
Date of Signature